

## DETERMINATION OF COLLISIONAL QUENCHING RATE COEFFICIENT OF $N_2(A^3\Sigma_u^+)$ BY XYLENE

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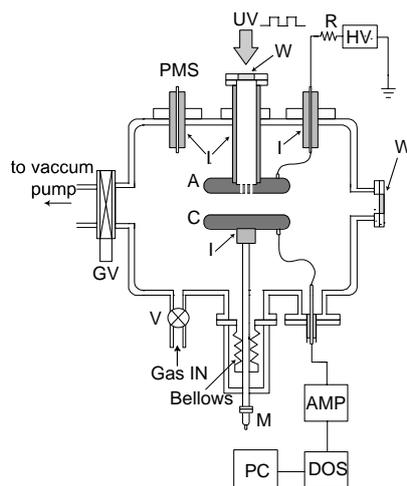
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The metastable nitrogen molecule  $N_2(A^3\Sigma_u^+)$  performs an important role as an active species in the reaction process in air plasma [1], which is considered to include various environmental pollution gases. We have previously determined the collisional quenching rate coefficient of  $N_2(A^3\Sigma_u^+)$  by air pollutant gases, such as CO, CH<sub>4</sub>, NO, CCl<sub>2</sub>F<sub>2</sub>, and CH<sub>2</sub>FCF<sub>3</sub> [2]-[4]. Recently, our investigation has expanded to gases that cause sick building syndrome such as benzene (C<sub>6</sub>H<sub>6</sub>), acetone ((CH<sub>3</sub>)<sub>2</sub>CO), toluene (C<sub>6</sub>H<sub>5</sub>CH<sub>3</sub>), and formaldehyde (CH<sub>2</sub>O) [5][6].

This paper deals with the determination of the collisional quenching rate coefficient of  $N_2(A^3\Sigma_u^+)$  by *m*-xylene (C<sub>8</sub>H<sub>10</sub>). Xylene is used as a solvent and a diluent in adhesives and paints. Among the three isomers of xylene, *m*-xylene, which has the weakest binding strength with methyl groups, is examined. The collisional quenching rate coefficients of  $N_2(A^3\Sigma_u^+)$  by xylene (*o*-xylene, *m*-xylene, and *p*-xylene) have not been reported to the best of the authors' knowledge. Therefore, this is the first report in which the quenching effect of  $N_2(A^3\Sigma_u^+)$  by xylene is described.

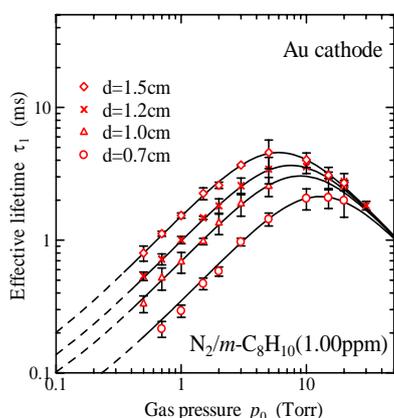
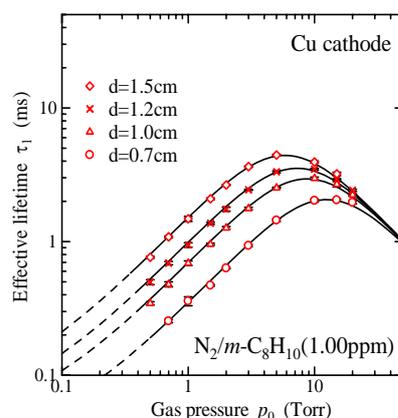
A schematic of the apparatus used in this study is shown in Fig. 1. Because the experimental apparatus and procedure have already been reported [2]-[6], The details are omitted here. The used gas is N<sub>2</sub> (purity 99.999%) mixed with *m*-C<sub>8</sub>H<sub>10</sub> (purity 99.5%) with a concentration of 1ppm, and a gold-plated cathode of Rogowski profile type and a copper disc cathode with 120 mm in diameter are prepared in the experiment.

Figure 2 shows the gas pressure dependence of the effective lifetime  $\tau_1$  of  $N_2(A^3\Sigma_u^+)$  measured using the Au cathode.  $\tau_1$  is determined from the slope of the decay of the transient current waveforms. The experimental data is plotted with a log-log scale with error bars representing the standard deviation. The effective lifetime increases with a slope of approximately unity with the gas pressure. The solid lines are obtained by a curve-fitting procedure based on our



AMP: High-speed current amplifier, DOS: Digital oscilloscope, PC: Personal computer, GV: Gate valve, HV: High voltage, PMS: Gas pressure measurement system, UV: UV light, M: Micrometer, V: Valve, W: Quartz window, A: Anode, C: Cathode, I: Insulator

Fig. 1. Schematic of the experimental apparatus.

Fig. 2. Effective lifetime of  $N_2(A^3\Sigma_u^+)$ .Fig. 3. Effective lifetime of  $N_2(A^3\Sigma_u^+)$ .

theory [6] using the present results. From these curves, the diffusion coefficient  $D_{m1}$ , the collisional quenching rate coefficient  $k'$  of  $N_2(A^3\Sigma_u^+)$  by *m*-xylene, and the reflection coefficient  $R$  are  $151 \text{ cm}^2/\text{s}$ ,  $4.8 \times 10^{-10} \text{ cm}^3/\text{s}$ , and 0.01, respectively.

Figure 3 shows the obtained effective lifetime of  $N_2(A^3\Sigma_u^+)$  measured using the copper disc cathode. Using the same curve-fitting procedure,  $D_{m1}$ ,  $k'$ , and  $R$  are  $152 \text{ cm}^2/\text{s}$ ,  $4.0 \times 10^{-10} \text{ cm}^3/\text{s}$ , and 0.1, respectively.

No significant difference is found between the results in Figs. 2 and 3 except for the reflection coefficient. The reflection coefficients of the electrode surface are 0.01 for the gold-plated cathode and 0.1 for the copper disc cathode.

In addition, the measured effective lifetimes are consistent with the theoretical curves shown in Figs. 2 and 3 by solid lines. This is a noteworthy feature of our experiment. The collisional quenching rate coefficients  $k'$  of  $N_2(A^3\Sigma_u^+)$  by air pollution gases that have been measured so far are shown in Table 1, in which  $k'$  for  $C_8H_{10}$  is the largest value.

Table 1. Collisional quenching rate coefficients  $k'$  of  $N_2(A^3\Sigma_u^+)$  by air pollutions.

Gases	$k'$ ( $\text{cm}^3\text{s}^{-1}$ )
<i>m</i> - $C_8H_{10}$	$(4.4 \pm 0.6) \times 10^{-9}$
$CF_4$	$(6.9 \pm 0.9) \times 10^{-16}$
$CH_4$	$(1.6 \pm 0.1) \times 10^{-15}$
$CH_2FCF_3$	$(2.9 \pm 0.6) \times 10^{-15}$
$C_2F_6$	$(2.9 \pm 1.0) \times 10^{-15}$
$CO_2$	$(3.8 \pm 0.4) \times 10^{-13}$
$CO$	$(5.9 \pm 1.7) \times 10^{-13}$
$CCl_2F_2$	$(8.3 \pm 0.2) \times 10^{-13}$
$CH_2O$	$(4.7 \pm 0.4) \times 10^{-12}$
$NO$	$(4.8 \pm 0.2) \times 10^{-11}$
$(CH_3)_2CO$	$(2.2 \pm 1.3) \times 10^{-10}$
$C_6H_6$	$(3.0 \pm 0.3) \times 10^{-10}$
$C_6H_5CH_3$	$(6 \pm 3) \times 10^{-10}$

## Reference

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